



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): A. Smith et al.
Serial No.: 10/775,718
Filed: February 9, 2004
Cust. No.: 33123
For: **METHOD AND
APPARATUS FOR SELF-
REFERENCED WAFER
STAGE POSITIONAL
ERROR MAPPING**
Examiner: K. Koyama

CERTIFICATE OF MAILING
PURSUANT TO 37 CFR 1.8

I hereby certify that this correspondence and the attached papers are being deposited with the United States Postal Service with sufficient postage as first class mail on the date indicated below in an envelope addressed to:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450, on

9/15/05
Date

Michelle Melendy
Signature

**PETITION PURSUANT TO 37 C.F.R. § 1.182 - QUESTIONS NOT SPECIFICALLY
PROVIDED FOR: REQUEST FOR ENTRY OF REPLACEMENT DRAWINGS**

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is a Petition pursuant to 37 C.F.R. § 1.182 to request the entry of replacement drawings in the publication of the above-identified application. The replacement drawings provided herewith are Formal Drawings. Therefore these drawings are of better quality than those originally filed. The drawings are properly and timely submitted, therefore Applicant respectfully request the entry of these replacement drawings in this application.

Respectfully submitted,
HELLER EHRMAN LLP

By: Alan C. Gordon
Alan C. Gordon
Registration No. 51,220

Address all correspondence to:

David A. Hall
HELLER EHRMAN LLP
4350 La Jolla Village Drive, 7th Floor
San Diego, CA 92122-1246
Telephone: (858) 450-8400 Facsimile: (858) 450-8499
Email: david.hall@hellerehrman.com
SD 759432 v1 (38203.6082)